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APPLICANTS Fumitsugu Fukuyo, Hamamatsu-shi, JAPAN; Kenshi Fukumitsu, Hamamatsu-shi, JAPAN; Naoki Uchiyama, Hamamatsu-shi, JAPAN; Ryuji Sugiura, Hamamatsu-shi, JAPAN; ** CONTINUING DATA ***************************** This application is a 371 of PCT/JP03/11624 09/11/2003 ** FOREIGN APPLICATIONS ************************************									
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